

Notice of References Cited	Application/Control No. 10/572,679	Applicant(s)/Patent Under Reexamination ONO ET AL.	
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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
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FOREIGN PATENT DOCUMENTS

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	N	2005-233398(A)	09-2005	Japan	Tomonori et al.	464/111
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NON-PATENT DOCUMENTS

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